



2020 ACM International Symposium on Physical Design
Wafer-Scale Deep Learning
Accelerator Placement Contest

THIRD PLACE

Team CUPID

Zhuolun He, Peiyu Liao, Ran Chen, Siting Liu,
Yuzhe Ma, Bei Yu
The Chinese University of Hong Kong

William Swartz
General Chair
ISPD2020

Jens Lienig
Technical Program Chair
ISPD2020

Marvin Tom, Michael James,
Vladimir Kibardin, Robby Fry,
Patrick Groeneveld,
Cerebras